

Electronic Acknowledgement Receipt

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Application Number:	10552513
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Title of Invention:	Crystalline-si-layer-bearing substrate and its production method, and crystalline si device
First Named Inventor:	Yasushi Araki
Customer Number:	23373
Filer:	Kelly G. Hyndman/LAYONDA PRUE
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Request for Corrected Filing Receipt	Q90689reqforcorrectedofr2ndscan.pdf	241867	no	6

Warnings:	
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